



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT

In re application of: Ricci *et al.*

Application No.: 09/408,921

Filed: September, 30, 1999

Title: PRETREATED GAS DISTRIBUTION PLATE

Attorney Docket No.:
LAM1P118/P0539

Examiner: A. Powell

Group: 1763

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Assistant Commissioner for Patents, Washington, DC 20231 on September 27, 2000.

Signed:

Jorge L. Ferreira
Jorge L. Ferreira

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10/4/00
MW

AMENDMENT

Assistant Commissioner for Patents
Box Non-Fee Amendment
Washington, D.C. 20231

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Sir:

This is in response to the Office Action mailed June 27, 2000.
Reconsideration of the captioned application is respectfully requested.

IN THE CLAIMS:

Please CANCEL claims 19-37 without prejudice or disclaimer.

Please AMEND claims 1, 2 and 5 as follows:

1. (Once Amended) A gas distribution plate for use in a semiconductor fabrication apparatus including a semiconductor processing chamber, the gas distribution plate comprising:

a plurality of holes for passing process gases to the semiconductor processing chamber; and